

In re application of

Confirmation No. 9516

Norio KIMURA et al.

Attorney Docket No. 2003-0865

Serial No. 10/601,789

Group Art Unit 3723

Filed June 24, 2003

Examiner Hadi Shakeri

APPARATUS FOR POLISHING A

SUBSTRATE

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AMENDMENT AFTER FINAL REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE UNDER 37.CFR1.116
EXPEDITED PROCEDURE
EXAMINING GROUP_3760

Sir:

In response to the Office Action of December 27, 2006, the period for response to which having been extended by three months to June 27, 2007, kindly amend the above-referenced U.S. patent application as follows:

THE COMMISIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975